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This invention relates in general to a plasma process technology, (ULSI) device fabrication and Uniformity in Inductively Coupled Plasma Sources," Oct. 1995,

"Advanced Process Technology for VLSI Circuits," Solid " Full Copper Wiring in a Sub-0.25 μ m CMOS ULSI Technology.- Process and Device

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Micromachining and microfabrication process technology. Bellingham, Wash. : SPIE, 1995

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